



- ✓ (2) 09/725299
- ✓ (2235) (cross near3 beam) and (position\$5 near3 system) and (table holder stage)
- ✓ (372) ((cross near3 beam) and (position\$5 near3 system) and (table holder stage)) and lithograph\$5
- ✓ (6060) field near3 emitter
- ✓ (3889) (field near3 emitter) and electron
- ✓ (175) ((field near3 emitter) and electron) and (conduction near3 band)
- ✓ (88) ((field near3 emitter) and electron) and (conduction near3 band) and tip
- ✓ (8) ("4460831" | "4820927" | "4906894" | "4970392" | "5039862" | "5557105" | "5684360" | "579910...")
- ✓ (0) 6005247.URPN.
- ✓ (334) 313/542
- ✓ (280) 313/542 and electron
- ✓ (22) (313/542 and electron) and tip
- ✓ (18) (313/542 and electron) and tip and light
- ✓ (1611) (field near3 emit\$5) and tip and light and electron
- ✓ (306) ((field near3 emit\$5) and tip and light and electron) and optics
- ✓ (25) "5684360"
- ✓ (5) "5684360" and tip
- ✓ (4) "5399860"
- ✓ (9) (minicolumn mini-column) and (electron near3 microscope)
- ✓ (104) (minicolumn mini-column) and electron
- ✓ (469) minicolumn mini-column
- ✓ (7) (minicolumn mini-column) and 250/\$
- ✓ (625) mini near3 column
- ✓ (16) ((mini near3 column) and electron) and 250/\$
- ✓ (170) (mini near3 column) and electron
- ✓ (120) (electron near3 microscope) and (mini\$9 near3 column)
- ✓ (16) "4864228"
- ✓ (22) "5229607"
- ✓ (959) microcolumn micro-column
- ✓ (316) (microcolumn micro-column) and electron
- ✓ (65) (microcolumn micro-column) and (electron near3 microscope)
- ✓ (22) (mounting near3 arm) and (electron near3 microscope)
- ✓ (0) emit\$7 and tip and (electron near4 source)
- ✓ (2377) emit\$7 and tip and (electron near4 source)
- ✓ (992) (emit\$7 and tip and (electron near4 source)) and (field near4 emitter)
- ✓ (151) ((emit\$7 and tip and (electron near4 source)) and (field near4 emitter)) and optics
- ✓ (93) (emit\$7 and tip and (electron near4 source)) and (conduction near3 band)
- ✓ (469) (emit\$7 and tip and (electron near4 source)) and lithography
- ✓ (310) (emit\$7 and tip and (electron near4 source)) and lithography and mask
- ✓ (167) ((emit\$7 and tip and (electron near4 source)) and lithography and mask) and (field near3 e...)
- ✓ (9) ("5731228" | "5773834" | "5773921" | "5872422" | "5969362" | "5973444" | "6023060" | "609713...")
- ✓ (105) ((emit\$7 and tip and (electron near4 source)) and lithography and mask) and (field near3 e...)
- ✓ (38) ((emit\$7 and tip and (electron near4 source)) and lithography and mask) and (field near3 em...)
- ✓ (6068) field near3 emitter
- ✓ (31) ((field near3 emitter) and (light) and lithography) and (conduction near3 band)
- ✓ (386) (field near3 emitter) and (light) and lithography
- ✓ (355) ((field near3 emitter) and (light) and lithography) not (((field near3 emitter) and (light...))
- ✓ (9) ("5731228" | "5773834" | "5773921" | "5872422" | "5969362" | "5973444" | "6023060" | "609713...")
- ✓ (0) 6512235.URPN.

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2	BRS	0	cross near3 beam)	USPAT; US-PGPUB; EPO	2004/01/06 09:38	Error executin 1